

Application Serial No. 10/738,398
 Reply to Office Action of September 29, 2005

NOV 30 2005

PATENT

Docket: CU-3402

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEdo not enter
CDW 12/7/05

In re Application: Yi Sun CHUNG

] GRP ART UNIT: 2891

Serial No: 10/738,398

] Ex.: Wilson, Christian D.

Filed: December 17, 2003

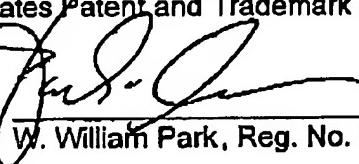
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For: METHOD FOR FORMING METAL-INSULATOR-METAL CAPACITOR OF
SEMICONDUCTOR DEVICECertification under 37 C.F.R. §1.8(a)

The USPTO Central Fax No. (571) 273-8300

Date of Fax Transmittal: November 30, 2005

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.



W. William Park, Reg. No. 55,523

AMENDMENT AFTER FINAL UNDER 37 CFR 1.116

MAIL STOP AF
 The Commissioner for Patents
 P.O. Box 1450
 Alexandria VA 22313-1450

Sir:

In response to the office action dated September 29, 2005, setting a 3-month shortened statutory period for a reply ending on December 29, 2005, the applicant submits the following responsive amendment in the above-identified application. This amendment is considered to place the application in better condition for allowance.

No fee is believed to be required with this amendment, but, if this is not the case, please charge the requisite fee (or credit any overpayment) to Deposit Account No. 12-0400.